

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Daisuke KOMADA, et al.

Serial No.: 10/058,426

Filed: January 30, 2002

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING  
SILICON CARBIDE FILM**



Group Art Unit: 1756

Examiner: BARRECA, Nicole M.

Confirmation No.: 4298

Attorney Docket No.: 020060

Customer Number: 38834

**RESPONSE UNDER 37 C.F.R. § 1.116**  
**- EXPEDITED RESPONSE -**

Mailstop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

July 20, 2004

Sir:

In response to the Office Action dated April 1, 2004, Applicant amends the claims as follows and submits the following remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.

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